Docket No.: 54024-039

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Naoki KUBO, et al.

Serial No.:

Group Art Unit:

Filed: February 05, 2002

Examiner:

For:

THREE-DIMENSIONAL MOLDING APPARATUS AND THREE-DIMENSIONAL

MOLDING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: February 5, 2002 Facsimile: (202) 756-8087

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION				ATTY. DOCKET NO. 54024-039 APPLICANT Naoki KUBO, et al.		SERIAL NO.		// U62542
(PTO-1449)				FILING DATE February 05, 2002		GROUP T		
U.S. PATENT DOCUMENTS								
EXAMINER'S INITIALS	PATENT NO.	DATE		NAME .	CLASS	SUBCLASS	FILING DATE	
INTIALS	4,937,420	6/26/1990	Deckard		02.100	00200.100		
	5,204,055	4/20/1993	Sachs et al.					
	5,387,380	2/7/1995	Cima et al.					
		FOR	EIGN PATE	NT DOCUMI	ENTS			
EXAMINER'S INITIALS	PATENT NO.	DATE	cc	UNTRY CLASS	SUBCLASS	Translation		
						Yes	No	
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	OTHER	X ART (IIICI)	ading Addition	, Title, Date, I	er timent r	ages, Etc.)		
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EXAMINER	2		l r	ATE CONSID	ERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.